

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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e Application of:

Reimer et al.

Serial No.: 09/220,153

Confirmation No.: 3858

Filed:

December 23, 1998

For:

**Processing Apparatus** 

Having Integrated Pumping System

Commissioner for Patents Washington, D.C. 20231

Dear Sir:

Group Art Unit: 1763

Examiner:

R. Bueker

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CERTIFICATE OF MAILING

37 CFR 1.8

I hereby certify that this correspondence is being deposited on September 30, 2002 with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231.

31 Sept 02

Signature

## RESPONSE TO REQUIREMENT FOR INFORMATION

In the Requirement for Information mailed July 31, 2002 the Examiner asked two specific questions related to an information disclosure statement filed by the Applicant July 25, 2002.

Specifically, the Examiner asked the following:

Is the pump that is described in the IDS filed July 25, 2002, capable of exhausting gas to atmospheric pressure?

In answer to the question, the pump that is described in the IDS is capable of exhausting gas to atmospheric pressure.

Does the pump that is described in the IDS filed July 25, 2002, include a controller for controlling the pressure in the vacuum chamber by changing the rotational speed of the pump?

In answer to the question, the pump that is described in the IDS does not include a controller for controlling the pressure in the vacuum chamber by changing the rotational speed of the pump.

The foregoing comments should satisfy the Request for Information mailed July 31, 2002.

Respectfully submitted,

William B. Patterson

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